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IN THE UNITED STATES
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Appl. No.: 09/754,277
Applicant(s): T. Sawayana
Filed: January 5, 2001
TC/A.U.: 1700/1763
Examiner: L. Alejandro Mulero
Atty. Docket: Oki.201
Title: Plasma Etching Apparatus

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On: August 5, 2003

By: William S. Francos
William S. Francos

AMENDMENT and/or RESPONSE after FINAL ACTION

Mail Stop **AF**
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Sir:

In response to the final Office action of May 5, 2003,
please amend the above referenced application as follows and
reconsider the application in light of the following remarks.



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This paper includes (each beginning on a separate sheet):

1. **Amendments to the Specification**, which begin on page 3 of this paper.
2. **Amendments to the Claims**, reflected in the complete listing of the claims, which begins on page 4 of this paper;
3. **Amendments to the Drawings**, which are described on page 7 of this paper, and are reflected in the Replacement Drawing sheet attached hereto.
4. **Remarks/Discussion of issues**, which begin on page 8 of this paper;